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To the Honorable Commissioner of Patents and Trademarks: Please record the attached original documents or copy thereof.

1. Name of conveying party(ies):

Fwu-Iuan Hshieh

Additional name(s) of conveying party(ies) attached? ☐ Yes ☒ No

3. Nature of conveyance:

- ☒ Assignment ☐ Merger
☐ Security Agreement ☐ Change of Name
☐ Other _____

Execution Date: Sept. 4, 2006

2. Name and address of receiving party(ies)

Name: Force-MOS Technology Corp. LTD.

Internal Address: _____

Street Address: _____

Grand Caymen, Cayman Island,

British West Indise

Additional name(s) & address(es) attached? ☐ Yes ☒ No112955 U.S. PTO
11/519754

091106

4. Application number(s) or patent number(s):

If this document is being filed together with a new application, the execution date of the application is: Sept. 4, 2006

A. Patent Application No.(s)

B. Patent No.(s)

Additional numbers attached? ☐ Yes ☒ No

5. Name and address of party to whom correspondence concerning document should be mailed:

Name: Bo-In Lin

Internal Address: _____

Street Address: 13445 Mandoli Drive

City: Los Altos Hills, State: CA Zip: 94022

6. Total number of applications and patents involved: ☒

7. Total fee (37 CFR 3.41).....\$ 40.00

☒ Enclosed☐ Authorized to be charged to deposit account

8. Deposit account number:

(Attach duplicate copy of this page if paying by deposit account)

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9. Statement and signature.

To the best of my knowledge and belief, the foregoing information is true and correct and any attached copy is a true copy of the original document.

Ching-lu Lin

Name of Person Signing

Signature

Sept. 11, 2006

Date

Total number of pages including cover sheet, attachments, and documents: 2

Mail documents to be recorded with required cover sheet information to:
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PATENT

REEL: 018308 FRAME: 0892

09/18/2006 DBYRNE 00000100 11519754

01 FC:8021 40.00 00

Docket No. Hshieh-0602

ASSIGNMENT

INVENTOR
AND CITYWhereas, I, Fwu-Iuan Hshieh of 20768 Sevilla Lane,
Saratoga, California 95070

have invented:

TITLE:

Trench MOSFET Device Configuration with Reduced Mask ProcessesDATE INVENTOR
SIGNED THE
DECLARATION

and executed a United States patent application therefor

on 4 Sept., 2006;

Whereas, **Force-MOS Technology Corp. LTD**, having a place of business at **Grand Cayman, Cayman Island, British West Indise** (hereinafter called **FTC**), desires to acquire the entire right, title and interest of said application and invention, and to any United States and foreign patents to be obtained therefor;

Now therefore, for a valuable consideration, receipt whereof is hereby acknowledged, I, the above named, hereby sell, assign, and transfer to **FTC**, its successors and assigns, the entire right, title and interest in the said application and invention therein disclosed for the United States and foreign countries, and all rights of priority resulting from the filing said United States application, and I request the Commissioner of Patents to issue any Letters Patent granted upon the inventions set forth in said application to **FTC** its successors and assigns; and I hereby agree that **FTC** may apply for foreign Letters Patent on said invention and I will execute all papers necessary in connection with the United States and foreign applications when called upon to do so by

CITY AND
DATESigned and Sealed at Shanghai, Chinaon 4 Sept., 2006.
SIGNATURE OF INVENTOR

PATENT